Application No.: 10/522,279



If w/ Inric

KIT 383-US (10500694) (PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Fujita

Application No.: 10/522,279

Confirmation No.: @@@

Filed: January 24, 2005

Art Unit: N/A

For:

METHOD AND APPARATUS FOR

Examiner: Not Yet Assigned

CULTURING PLANT

INFORMATION DISCLOSURE STATEMENT (IDS)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned (37 CFR 1.97(b)(3)).

A summary/abstract translation of the non-English language references is enclosed for some of the references.

A copy of each reference on the PTO/SB/08 is attached.

In accordance with 37 CFR 1.97(g), the filing of this Information Disclosure Statement shall not be construed to mean that a search has been made or that no other material information as defined in 37 CFR 1.56(a) exists. In accordance with 37 CFR 1.97(h), the filing of this Information Disclosure statement shall not be construed to be an admission that any patent, publication or other information referred to therein is "prior art" for this invention unless specifically designated as such.

25543867.1

Application No.: 10/522,279

It is submitted that the Information Disclosure Statement is in compliance with 37 CFR 1.98 and the Examiner is respectfully requested to consider the listed references.

The Director is hereby authorized to charge any deficiency in the fees filed, asserted to be filed or which should have been filed herewith (or with any paper hereafter filed in this application by this firm) to our Deposit Account No. 50-0624, under Order No. NY-KIT 383-US.

Respectfully submitted,

By

C. Andrew Im

Registration No.: 40,657

FULBRIGHT & JAWORSKI L.L.P.

666 Fifth Avenue

New York, New York 10103

(212) 318-3000

(212) 318-3400 (Fax)

Attorney for Applicant

PTO/SB/08A (10-01)

Approved for use through 10/31/2002.OMB 0651-0031

				respond to a collection of information unless it contains a valid OMB control numb Complete if Known			
NY& TH	ostitute of form 1449A/PTO			Application Number	10/522,279		
INFORMATION DISCLOSURE				Filing Date	January 24, 2005		
S	STATEMENT I	3Y /	APPLICANT	First Named Inventor	Fujita		
				Art Unit	N/A		
	(use as many sh	eets as	necessary)	Examiner Name	Not Yet Assigned		
Sheet	1	of	1	Attorney Docket Number	NY-KIT 383 US (10500694)		

			U.S.	PA	TENT DO	CUMENTS			
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication E MM-DD-YY		Naı	me of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	
	AA	US-5,858,309	01/12/99	Mathus, e		et al.			
			FOREI	GN	PATENT	DOCUMENTS			
Examiner Initials*	Cite No.1	Foreign Patent Docum Country Code ³ -Number ⁴ -Kind Co			olication Date M-DD-YYYY	Name of Patentee or Applicant of Cited Document		Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ⁶
	ВА	JP-09-033411 A			/07/97	Nitto Shoji KK			
	ВВ	JP-2002-139418 A		05	/17/02	Nikon Corp.			
	ВС	JP-2-7553		01	/18/90	Aloka Co., Ltd.			
	BD	JP-3-69852 B2		11,	/05/91	Toshiba Corp.			
	BE	JP-08-129014 A		05	/21/96	Dainippon Ink and Chem. Inc	c. et		
	BF	JP-6-95073 B2		11,	/24/94	Dir. General, Agency of Indus Science and Technology	strial		
	BG	WO-01/62887 A1		08	/30/01	01 Zyomyx, Inc.			1
	вн	JP-7-2955		01	01/17/95 Aloka Co., Ltd			1	
	ВІ	JP-10078388		03,	3/24/98 Corning Costar Corp.				
	вк	JP-2003-524193 A		08	/12/03	3 Zyomyx. Inc.			1
	BL	EP-797088 A		03,	/1998	8 Corning Costrar Corp.			1
	вм	JP 59-15839		01,	/1984	Toshiba Corp.			
									1
									1
									1
				ļ					

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

¹ Applicant's unique citation designation number (optional). ² See attached Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

	T I	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the	
Examiner Initials	Cite	item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s),	T2
	No.'	publisher, city and/or country where published.	- 1

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Examiner Signature		Date Considered	
25542077 4	000		

¹Applicant's unique citation designation number (optional). ²Applicant is to place a check mark here if English language Translation is attached.